



10/643,534.

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant: Cyril Cabral Jr., et al.**

**Docket: 16695**

**Patent No.: 6,943,097**

**Dated: March 06, 2006**

**Issued: September 13, 2005**

**For: ATOMIC LAYER DEPOSITION OF  
METALLIC CONTACTS, GATES AND  
DIFFUSION BARRIERS**

**Certificate**

**MAR 15 2006**

**of Correction**

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**REQUEST FOR CERTIFICATE OF CORRECTION**

**Sir:**

**It appears that errors have been introduced in the course of printing  
the Patent issued in the above application, and it is respectfully requested that the  
Commissioner issue a Certificate of Correction in the following respects:**

**Column 4, Line 21:**

**"thereof An" should read -- thereof. An --**

**Respectfully submitted,**

**Leslie S. Szivos  
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**UNITED STATES PATENT AND TRADEMARK OFFICE  
CERTIFICATE OF CORRECTION**

PATENT NO : 6,943,097  
APPLICATION NO : 10/643,534  
ISSUE DATE : September 13, 2005  
INVENTOR(S) : Cyril Cabral Jr., et al.

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 4, Line 21:  
"thereof An" should read -- thereof. An --

MAILING ADDRESS OF SENDER:

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PATENT No. 6,943,097

No. of additional copies

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